

ABSTRACT OF DISCLOSURE

An apparatus for punching CMP machine backing film. The apparatus comprises a base, a first plate, and a second plate.

5 The base holds the backing-film. The first plate is disposed on the base in a manner such that it moves between a first position and a second position. The first plate abuts the backing-film when it is located at the second position. The second plate, having a plurality of punches, is disposed on

10 the base in a manner such that it moves between a third position and a fourth position. The first plate is located at the first position when the second plate is located at the third position. The first plate is located at the second position when the second plate is located at the fourth

15 position so that the punches pass through the first plate to punch the backing-film.